

<b>Notice of References Cited</b>	Application/Control No. 09/759,721	Applicant(s)/Patent Under Reexamination KIM, YEONG-TAEG	
	Examiner Scott Beliveau	Art Unit 2614	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,532,735	07-1996	Blahut et al.	725/32
	B	US-6,282,713	08-2001	Kitsukawa et al.	725/36
	C	US-6,029,045	02-2000	Picco et al.	725/34
	D	US-5,886,731	03-1999	Ebisawa, Kan	725/32
	E	US-6,564,379	05-2003	Knudson et al.	725/42
	F	US-2003/0115612	06-2003	Mao et al.	725/136
	G	US-2002/0007493	01-2002	BUTLER et al.	725/109
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.